

**SUPPLEMENTAL FORM PTO-1449**

**\*EXAMINER:** Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT BY APPLICANT		ATTY. DOCKET NO. 102094-100		SERIAL NO.		
		APPLICANT: Laurello et al.				
		FILING DATE: Herewith		GROUP		
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPR.
ML	3,767,391	10/23/1973	Tucillo	75	134C	May 19, 1969
ML	3,940,303	02/24/1976	Caule	156	316	Mar. 26, 1973
ML	4,113,475	09/12/1978	Smith	75	159	Feb. 17, 1977
ML	4,204,883	05/27/1980	Smith	148	2	Aug. 30, 1978
ML	4,255,191	03/10/1981	Kropp	75	134	Feb. 20, 1980
ML	4,468,293	08/28/1984	Polan et al.	204	27	Jan. 24, 1983
ML	4,490,218	12/25/1984	Kadija	204	13	Nov. 07, 1983
ML	4,493,736	01/15/1985	Adams	148	2	Oct. 05, 1983
ML	4,663,245	05/05/1987	Yoshida	428	632	May 16, 1985
ML	4,917,967	04/17/1990	Cupolo et al.	428	669	Jan. 13, 1989
ML	5,028,492	07/02/1991	Guenin	428	614	Mar. 13, 1990
ML	5,300,158	04/05/1994	Chen et al.	148	258	May 26, 1992
ML	5,332,486	07/26/1994	DiFranco	205	50	Jan. 29, 1993
ML	5,343,073	08/30/1994	Parthasarathi et al.	257	666	Jan. 06, 1993
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION Yes No
ML	Kokai Patent No. Hei 3(1991)-239353	10/24/1991	Japan	—	—	X
ML	PCT/WO 99/51363	14 Oct. 1999		—	—	
OTHER DOCUMENTS (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)						
1. ML	Britton et al., "An Examination of Oxide Films on Tin and Tinplate", <i>Metallurgia</i> , October, 1957, pp. 163-167					
EXAMINER:	DATE CONSIDERED: 9/16/02					
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